

1-44. (CANCELED)

45. (CURRENTLY AMENDED) A high reflectivity micro mirror, comprising:

a homogenous monolithic bulk crystal silicon having an anisotropic body ◆◆  
with several crystalline planes;

C, a mirror surface co-extensive with an anisotropically etched portion of a  
selected one of the several crystalline planes positioned internally within the body; and

an inlet passage and an outlet passage anistropically etched independent ◆◆  
of crystalline planes, which intersect at the selected one of the several crystalline ◆◆  
planes.

46-62. (CANCELED).